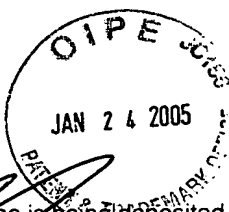


Docket No.: P2001,0337



*DFW*

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

By: \_\_\_\_\_

Date: January 19, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/713,690 Confirmation No: 2926  
Applicant : Rolf Heine et al.  
Filed : November 14, 2003  
Title : Method for Performing an Alignment Measurement of Two  
Patterns in Different Layers on a Semiconductor Wafer  
Art Unit : 2825  
Examiner : Belur V. Keshavan  
  
Docket No. : P2001,0337  
Customer No. : 24131

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. 1.97(i)

Hon. Commissioner for Patents

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 5,952,134 (Hwang), dated September 14, 1999;

United States Patent No. 5,958,632 (Sekiguchi), dated September 28, 1999;

United States Patent No. 6,063,529 (Hwang), dated May 16, 2000;

United States Patent No. 6,077,756 (Lin et al.), dated June 20, 2000;

United States Patent No. 6,181,302 B1 (Lynde), dated January 30, 2001.

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 JAN 24 2005  
 PATENT & TRADEMARK OFFICE

FORM PTO-1449 (SUBSTITUTE)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	<table style="width: 100%;"> <tr> <td style="width: 50%;">Attorney Docket No.: P2001,0337</td> <td style="width: 50%;">Applic. No. 10/713,690</td> </tr> <tr> <td colspan="2">Applicant <div style="text-align: center;">Rolf Heine et al.</div></td> </tr> <tr> <td>Filing Date November 14, 2003</td> <td>Group Art Unit 2825</td> </tr> </table>	Attorney Docket No.: P2001,0337	Applic. No. 10/713,690	Applicant <div style="text-align: center;">Rolf Heine et al.</div>		Filing Date November 14, 2003	Group Art Unit 2825
Attorney Docket No.: P2001,0337	Applic. No. 10/713,690						
Applicant <div style="text-align: center;">Rolf Heine et al.</div>							
Filing Date November 14, 2003	Group Art Unit 2825						

**U.S. PATENT DOCUMENTS**

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,952,134	09/14/99	Hwang			
	B	5,958,632	09/28/99	Sekiguchi			
	C	6,063,529	05/16/00	Hwang			
	D	6,077,756	06/20/00	Lin et al.			
	E	6,181,302 B1	01/30/01	Lynde			
	F						
	G						
	H						
	I						

**FOREIGN PATENT DOCUMENT**

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO	
	J							
	K							
	L							
	M							
	N							

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)**

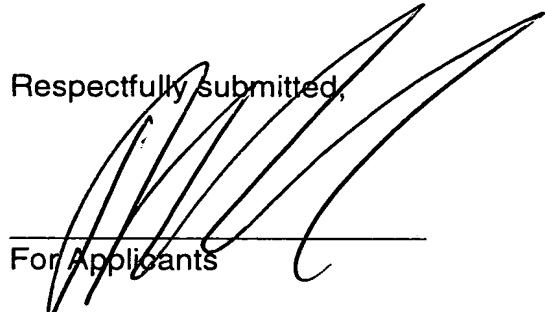
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EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

As per the Notice in 1273 OG 55 (August 5, 2003) no copies of any above-mentioned U.S. patents and U.S. patent application publications are submitted for any application filed after June 30, 2003.

It is believed that the enclosed prior art is less pertinent than the prior art previously submitted and cited by the Examiner. Kindly place the references in the Patent Office file wrapper.

Respectfully submitted,

  
\_\_\_\_\_  
For Applicants

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REG. NO. 41,947

Date: January 19, 2005

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/bmb